

INFORMATION DISCLOSURE STATEMENT

Pursuant to MPEP § 609, Applicants understand that the Examiner will, as part of his examination of this application, consider the art of record in the parent application. A form PTO-1449 is enclosed, citing the art of record in the parent application, but, pursuant to MPEP § 609, no new copies of such art are provided; should the Examiner wish to have such submitted, however, Applicants will gladly do so upon request.

The Examiner's attention is also directed to the following U.S. application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/413,773	10/7/99	2879

A copy of the cited application is enclosed.

Listed U.S. Patent No. 6,420,825, issued from Application No. 09/394,319, of record in parent U.S. Patent Application 09/413,774. One copy of U.S. Patent 6,420,825 is enclosed.

CONCLUSION

Favorable consideration and early passage to issue are requested, as is consideration of the art cited on the Form PTO-1449.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicants

Registration No. 42476

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
400200v1

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i>				ATTY DOCKET NO. 03500.014055.1		APPLICATION NO. NYA	
				APPLICANT NOBUHIRO ITO ET AL.			
				FILING DATE FILED HEREWITH		GROUP 2879	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,420,825	7/02	Shinjo et al.	313	495	
		4,904,895	2/90	Tsukamoto et al.	313	336	
		5,029,314	7/91	Katsumi et al.	355	208	
		5,066,883	11/91	Yoshioka et al.	313	309	
		5,523,834	6/96	Ito	355	315	
		5,729,802	3/98	Hirabayashi et al.	399	174	
		5,760,538	6/98	Mitsutake et al.	313	422	
		5,970,285	10/99	Ito et al.	399	149	
		5,995,786	11/99	Ito	399	150	
		5,939,822	8/99	Alderson	313	493	
		6,222,313	4/01	Smith et al.	313	495	
		5,811,919	9/98	Hoogsteen et al.	313	422	
		5,726,529	3/98	Dean et al.	313	495	
		6,236,157	5/01	Pan et al.	313	495	
		6,153,973	11/00	Shibata et al.	313	495	
		5,561,340	10/96	Jin et al.	313	309	
		5,598,056	1/97	Jin et al.	313	309	
		5,704,820	1/98	Chandross et al.	445	24	
		6,005,540	12/99	Shing et al.	345	74	
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4,181,870	1/80	Stevens	313	414	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		64-31332	2/89	Japan			Abstract
		2-257551	10/90	Japan			Abstract
		3-55738	3/91	Japan			Abstract
		4-28137	1/92	Japan			Abstract
		8-180821	7/96	Japan			Abstract
		10-144203	5/98	Japan			Abstract
		405262	1/91	EPO			
		0 851 458	1/98	EPO			
		725418 A1	8/96	EPO			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		W. P. Dyke et al, "Field Emission", Advances in Electronics and Electron Physics, 1956, Vol. VIII, pp. 89-185.					
		C. A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, April 1961, Vol. 32, No. 4, pp. 646-652.					
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 1972, pp. 317-328.					
		M. Hartwell et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", IEDM Technical Digest, 1975, pp. 519-521.					
		M. I. Elinson et al., "The Emission of Hot Electrons and the Field Emission of Electrons from Tin Oxide", Radio Engineering and Electronic Physics, July 1965, pp. 1290-1296.					
		C. A. Spindt et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, December 1976, Vol. 47, No. 12, pp. 5248-5263.					
		H. Araki et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum Society of Japan, January 1983, Vol. 26, No. 1, pp. 22-29.					
		R. Meyer, "Recent Development on 'Microtips' Display at Leti", Technical Digest of IVMC 91, 1991, pp. 6-9.					
EXAMINER				DATE CONSIDERED			

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